

<b>Notice of References Cited</b>	Application/Control No. 10/822,284	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Christine T. Mui	Art Unit 1709	Page 1 of 1

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*	C	US-6,599,407	07-2003	Taniike et al.	204/403.1
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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